



John

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 3652
Examiner: James J. Keenan

In Re PATENT APPLICATION OF:

Applicants : Muh-Wang LIANG et al.)
Serial No. : 09/619,388)
Filed : July 19, 2000)
For : APPARATUS FOR)
LOADING/UNLOADING WAFERS)
TO AND FROM SEMICONDUCTOR)
FABRICATION EQUIPMENT)
Attorney Ref. : LIE 105)

AMENDMENT

August 23, 2004

Mail Stop Non-Fee Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

Dear Sir:

This is in response to the Office Action dated June 23, 2004 in connection with the above-identified patent application. Please amend the subject patent application as follows: